

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of	:	Attorney Docket No. 2006_1372A
Norikazu SUGAYA et al.	:	<b>Confirmation No. 1096</b>
Serial No. 10/590,503	:	Group Art Unit 1715
Filed August 24, 2006	:	Examiner William P. Fletcher
METHOD OF PREVENTING ELUTION OF NICKEL FROM WETTED INSTRUMENT OF COPPER ALLOY, PROTECTIVE FILM FORMATION AGENT FOR PREVENTING ELUTION OF NICKEL AND DETERGENT FOR PREVENTING ELUTION OF NICKEL	:	<b>Mail Stop: AF</b>

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**RESPONSE TO FINAL REJECTION**

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

In response to the Final Rejection dated December 7, 2010, the period for response having been extended for one-month, please amend the present application as follows: